

INFORMATION DISCLOSURE STATEMENT

Applicant	:	Edman et al.
App. No	:	10/722,306
Filed	:	November 24, 2003
For	:	USE OF ELECTRIC FIELDS TO MINIMIZE REJECTION OF IMPLANTED DEVICES AND MATERIALS
Examiner	:	R. R. Holmes
Art Unit	:	3762
Conf No.	:	9308

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Dear Sir:

Enclosed for filing in the above-identified application is a PTO/SB/08 Equivalent listing two references, of which two are enclosed/submitted.

This Information Disclosure Statement is being filed before the mailing date of a final action and before the mailing date of a Notice of Allowance.

CERTIFICATION UNDER 37 C.F.R. § 1.97(e)(1)


I hereby certify that each item of information contained in this Statement was first cited in any communication from a foreign Patent Office in a counterpart foreign application not more than three months prior to the filing of this Information Disclosure Statement.

Application No.: 10/722,306
Filing Date: November 24, 2003

Thus, no fee is required as set forth in 37 C.F.R. § 1.97(c), however, the Commissioner is hereby authorized to charge any additional fees which may be required or to credit any overpayment to Account No. 11-1410..

Respectfully submitted,
KNOBBE, MARTENS, OLSON & BEAR, LLP

Dated: 1/14/10

By: 
Thomas R. Arno
Registration No. 40,490
Attorney of Record
Customer No. 20,995
(619) 235-8550

8387002
011410